

**PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1751**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroji AGA et al.

Group Art Unit: 2813

Application No.: 10/507,175

Examiner: C. RODGERS

Filed: September 10, 2004

Docket No.: 121026

For: METHOD OF PRODUCING SOI WAFER AND SOI WAFER

**AMENDMENT AFTER FINAL REJECTION  
UNDER 37 CFR §1.116**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the March 2, 2007 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**